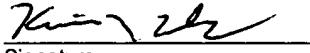


**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
DESIGNATED/ELECTED OFFICE (DO/EO/US)
CONCERNING A SUBMISSION UNDER 35 U.S.C. 371**

In re Application of: Ling CHEN, et al.	§ § §	Int'l Application No.: PCT/US2004/016715
Serial No.: to be assigned	§ §	Int'l Filing Date: 27 May 2004 (27.05.2004)
Filed: herewith	§ §	Priority Date: 27 May 2003 (27.05.2003)
For: METHOD AND APPARATUS FOR GENERATING A PRECURSOR FOR A SEMICONDUCTOR PROCESSING SYSTEM	§ § § § §	

MAIL STOP PCT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

CERTIFICATE UNDER 37 CFR 1.10	
<p>I hereby certify that this correspondence and the documents referred to as attached therein are being deposited on August <u>24</u>, 2006, with the United States Postal Service in an envelope as "Express Mail Post Office to Addressee," mailing label No. EV763975127US, addressed to: Mail Stop PCT, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.</p>	
<u>8/24/06</u> <small>Date</small>	 <small>Signature</small>

PRELIMINARY AMENDMENT

Prior to examination, please amend the above-identified application as follows.

Amendments to the Specification begin on page 2 of this paper. **The Pending Claims** are reflected in the listing of claims which begins on page 3 of this paper. **Remarks** begin on page 9 of this paper.